3729-IFW

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re application of:

WARREN M. FARNWORTH SALMAN AKRAM

Serial No.: 09/844,532

EXAMINER: Chang, R.

Filing Date: April 30, 2001

Art Unit: 3729

For: METHOD FOR FABRICATING A TEST

INTERCONNECT FOR BUMPED SEMICONDUCTOR COMPONENTS BY FORMING RECESSES AND CANTILEVERED LEADS ON A SUBSTRATE

(AS AMENDED)

Attorney Docket No. 97-1433.1

## **AMENDMENT**

## December 3, 2004

Mail Stop Amendment Commissioner For Patents PO Box 1450 Alexandria, VA 22313-1450

## Sir:

This Amendment is in response to the Office Action dated 07/20/2004, having a statutory period for response set to expire on 08/20/2004, but extended for four months by the enclosed Petition For Extension Of Time until 12/20/2004. Please amend the captioned case as follows.